

PATENT  
Atty. Dkt. AMAT/5320.Y1/DSM/BCVD/JW

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

E. Schieve

Serial No.: 09/755,516

Confirmation No.: 5078

Filed: January 4, 2001

For: Apparatus Having Platforms  
Positioned for Precise  
Centering of Semiconductor  
Wafers During Processing

Group Art Unit: 1763

Examiner: K. Moore

# OFFICIAL

## MAIL STOP

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

### CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703/872-9311 to the attention of the named Examiner, on the date below.

8/18/03  
Date

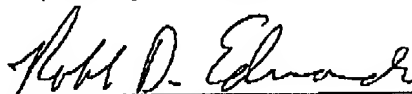
Robb D. Edmonds  
Signature

## PETITION FOR ONE-MONTH EXTENSION OF TIME

Applicant respectfully petitions the Commissioner under 37 CFR 1.136(a) to grant a one-month extension of time to and including August 28, 2003, in which to file the Response to Office Action Dated April 28, 2003.

This form is filed in duplicate. The Commissioner is authorized to charge the fee of \$110.00 and any additional fees which may be required for this submission to Deposit Account No. 20-0782/AMAT/5320.Y1/RDE.

Respectfully submitted,



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